

Quantum magnetomechanics: towards the ultra-strong coupling regime

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In this paper we investigate a hybrid quantum system comprising a mechanical oscillator coupled via magnetic induced electromotive force to an LC resonator. We derive the Lagrangian and Hamiltonian for this system and find that the interaction can be described by a charge-momentum coupling with a strength that has a strong geometric dependence. We focus our study on a mechanical resonator with a thin-film magnetic coating which interacts with a nano-fabricated planar coil. We determine that the coupling rate between these two systems can enter the strong, ultra-strong, and even deep-strong coupling regimes with experimentally feasible parameters. This magnetomechanical configuration allows for a range of applications including electro-mechanical state transfer and weak-force sensing.

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I. INTRODUCTION

Coupling between electromagnetic and mechanical degrees of freedom is central to a number of quantum science experiments and enables the development of many quantum technologies. Mechanical oscillators can act as coherent interfaces between different electromagnetic fields [1–3] and are a promising tool for the development of future quantum technologies oriented to communications, memories and metrology. Additionally, due to their relatively large mass, mechanical systems offer a promising route to perform fundamental tests of quantum physics [4–8]. A multitude of approaches in both opto- and electro-mechanics have been suggested and experimentally studied such as suspended mirrors forming an optical cavity with variable cavity length [9], microtoroids carrying whispering gallery modes [10], LC resonators with a mobile drum mode capacitor [11, 12], the motion of superfluid [13, 14] and nano-phononic crystals [15].

The basic coupling in optomechanics and electromechanics is fundamentally similar but physically different. In both cases a mechanical displacement produces a shift in the resonance frequency of an electromagnetic resonator. In optomechanics optical resonators are formed by mobile elements that changes the length of the cavity. In electromechanics, capacitors used in LC circuits are commonly formed by one mobile plate, so the resonance frequency is position dependent. Since the optomechanical coupling rate is related to the momentum transfer between the photon and a mechanical oscillator [16], it is usually small, such that reaching beyond the strong coupling regime is complicated. In recent literature, the term optomechanics is used to refer to both opto- and electro-mechanical systems [17], we follow this convention here.

At the quantum level, many experimental control protocols require quantum-coherent exchange of excitations between the light and mechanical systems, which is possible when the optomechanical interaction is faster than the dissipation of the light and mechanics, known as strong coupling condition. Significant progress has been made in a variety of architectures that enables this strong coupling to be observed [11, 18]. Strongly coupled systems have been used for instance, to cool down the state of motion of mechanical oscillators to their ground state [12, 19] and the preparation of entangled states of motion of a macroscopic mechanical oscillator [20]. The magnitude of the coupling rate defines two other main regimes that remain unexplored in optomechanics. The first one, referred to as ultra-strong coupling regime is accessible when the coupling rate is considerable fraction of the resonance frequency [21]. In optomechanical systems, this regime have been proposed to exhibit novel physics at the quantum level [22, 23]. If the optomechanical coupling gets strong enough that at least equals the mechanical resonance frequency, the second unexplored regime becomes accessible, the so called deep-strong coupling regime. This regime appears challenging to reach with existing optomechanical approaches, while recently achieved in superconducting qubits [24].

Approaches that explore mechanical oscillators coupled to electric circuits through magnetic interactions have been referred to as *magnetomechanics* and has been little explored compared to electromechanics [25]. Quantum magnetomechanics explores different techniques to prepare and control quantum states of motion of a mechanical oscillator using magnetic interactions. Several approaches to quantum magnetomechanics have been proposed and include magnetically levitated mechanical oscillators with the aim of reduce decoherence [26, 27], and coupling the motion of a mechanical oscillator to a superconducting circuit [28]. The applications of quantum magnetomechanics

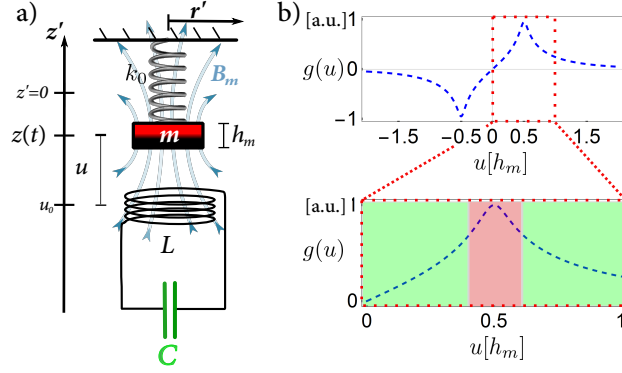


FIG. 1: a) Simplified scheme of the magnetomechanical system described in cylindrical coordinates z' and r' . A cylindrical magnet of mass m and thickness h_m attached to a spring of stiffness k_0 forms a mechanical oscillator. The mechanical oscillator is inductively coupled to an LC resonator. The magnet produces a magnetic field $\mathbf{B}_m$ that induces a flux in the inductor L placed at $z' = u_0$, which is connected to a capacitor C . The equilibrium position of the center of mass of the magnet is $z' = u_0$ and it displaces $z(t)$ around it. b) Coupling rate $g(u)$ which is proportional to the Faraday flux force on the magnet, as a function of the separation between the magnet and the coil u . The region where the linear (green) interaction is presented on both sides and where the dominant interaction is quadratic (red) is in the center.

can be expanded to systems with intrinsic magnetic properties such as electric circuits, superconducting qubits [29] or spin qubits [30].

In this paper we re-examine an electromechanical scheme, dating back as far as 1980 [6] that utilizes inductive coupling, placing it on a solid theoretical formulation by deriving the Lagrangian and the associated Hamiltonian. We further explore experimental regimes that may be achieved using modern fabrication techniques. The magnetomechanical system that we study is composed of a mechanical oscillator coupled magnetically to an LC resonator as shown in Fig. 1a. In contrast to optomechanics, where the mediating force is due to the radiation pressure, in our magnetomechanical system the mediating force is the Lorentz force. Using micro/nano fabricated designs which are experimentally achievable we find that strong, ultra-strong, and even deep-strong coupling is feasible. An outline of the paper is as follows: in section II we determine the Lagrangian of the coupled mechanical- LC system and then derive the quantized Hamiltonian. The quantum Hamiltonian exhibits either an adjustable linear or quadratic coupling (section III). In the linear coupling regime (section III A) we find that the LC circuit couples to the mechanical momentum identical to the velocity sensor studied in [6]. This linear dependence of the mechanical momentum breaks time reversal symmetry. Properties of the proposed experimental device are discussed in section IV where we consider an implementation with high Q mechanical oscillators and a superconducting LC resonator.

II. SEMI-CLASSICAL PICTURE

We consider an small cylindrical magnet and define a cylindrical coordinate system (r', z') . This magnet has an effective mass m and it is attached to a spring with spring constant k_0 , forming a mechanical oscillator with mechanical resonance frequency $\omega_m = \sqrt{k_0/m}$ (Fig. 1a). The magnet is placed at its equilibrium position where we fix the origin of the coordinate system $z' = 0$. The position of the center of mass of the magnet $z(t)$ is free to move along the z' direction. As it does, the mechanical motion creates an AC magnetic field. This AC magnetic field is coupled, via mutual inductance, to a nearby LC circuit. The coupled LC circuit-mechanical system behaves as two coupled oscillators. The coupling rate g between these two oscillators is strongly dependent on the geometry. In Fig. 1a, we show a schematic set-up of the magnetomechanical system where a cylindrical magnet generates a magnetic field $\mathbf{B}_m(z', r') = B_z \mathbf{e}_{z'} + B_r \mathbf{e}_{r'} = -\nabla \Phi_m(z', r')$. The scalar magnetic potential $\Phi_m(z', r')$ describes a cylindrical magnetic field distribution and $B_z(z', r')$ ($B_r(z', r')$), is the axial (radial) component of the magnetic field [31].

An electric coil is placed vertically below the magnet at $z' = u_0$. The relative vertical separation u between the magnet and the coil is $u = z(t) - u_0$. We define the geometrical path of the coil in three dimensions via a vector path $\mathbf{S}$. We now estimate the magnitude of the magneto-mechanical coupling strength g by analysing the magnetic flux induced by the magnet through the coil and by Faraday's law

$$g(u) = \frac{1}{\sqrt{mL}} \oint_{\text{coil}} \mathbf{B}_m(u) \times d\mathbf{S}. \quad (1)$$

In Fig.1b we plot the coupling rate $g(u)$ as a function of u , the separation between the magnet and the coil, which can be freely controlled in an experiment. We set the initial equilibrium separation u_0 , with $u_0/h_m \in [0, 1]$ where h_m is the thickness of the magnet (Fig. 1a), and highlight in green (red) the linear (quadratic) coupling regimes. Following Faraday's law of induction, the net force on the magnet is proportional to $g(u)$. The small displacement of the magnet around u_0 , allows us to expand $g(u) \rightarrow g(u_0 + z(t))$ as a function of z , the canonical coordinate of the center of mass mechanical motion. The expanded expression for small displacements around u_0 is $g(z) \approx g_0 + g_1 z + g_2 z^2/2$ where $g_j = \partial^j g(z)/\partial z^j|_{z'=u_0}$. The function $g(z)$ has two different behaviours, linear $g_1 z$ and quadratic $g_2 z^2/2$ depending on the choice of the equilibrium separation u_0 . When the coil inductor is connected to a capacitor as represented in Fig. 1a, the combined device forms a magnetomechanical system, wherein the field of the magnet induces current flow in the circuit, while the circuit back acts on the magnet. The LC circuit with resonance frequency $\omega_e = 1/\sqrt{LC}$ has a dissipation rate $\gamma_e = R/L$, where R is the resistance of the entire circuit. The general equation of motion for the LC resonator is, as usual

$$L\ddot{q}(t) + L\gamma_e\dot{q}(t) + L\omega_e^2 q(t) = V_{ext}(t), \quad (2)$$

where $V_{ext}(t)$ denotes the external driving voltage. The source of external voltage $V_{ext}(t)$ is the electromotive force (EMF) $\mathcal{E} = -\partial\Phi_B/\partial t$. The EMF is produced by the change in magnetic flux Φ_B crossing the transverse area enclosed by the inductor L as the mechanical oscillator displaces vertically. We estimate the EMF in terms of the coupling rate and obtain $\mathcal{E} = g(z)\dot{z}(t)/\sqrt{Lm}$. The induced EMF generates a current in the LC circuit, coupling the mechanical system to the electric system through the magnetic interaction. At the same time, the LC resonator with electric charge $q(t)$ and current $\dot{q}(t)$ generates a magnetic field.

The Lorentz force can be expressed as $F_L = -g(z)\dot{q}(t)/\sqrt{Lm}$, between the moving magnet and the static coil. The equation of motion for the damped mechanical oscillator is given by the standard expression

$$m\ddot{z}(t) + m\gamma_m\dot{z}(t) + m\omega_m^2 z(t) = F_{ext}(z, t), \quad (3)$$

where γ_m is the mechanical damping rate and $F_{ext}(z, t)$ is the sum of all the external vertical forces acting on the oscillator, which includes the Lorentz force on the magnet from the circuit. Here we treat the Lorentz force $F_L(z, t)$ as the dominant force acting on the magnet so $F_{ext}(z, t) = F_L(z, t)$. As $g(z)$ has a term that is non-linear in $z(t)$, the Lorentz force can be expanded as $F_L(z, t) = F_{L0}(t) + F_{NL}(z, t)$, where $F_{L0}(t) = -\sqrt{Lm} g_0 \dot{q}(t)$ is the Lorentz force at the equilibrium separation u_0 . Considering the expansion of the coupling rate $g(z)$, the non-linear force terms can be expressed as $F_{NL}(z, t) = -\sqrt{Lm} g_j \dot{q}(t) z^j(t)$ for $j = 1, 2$ that are shown as regions green and red respectively in Fig. 1b. This non-linear force depends on the small motional oscillation $z(t)$ of the magnet. The following analysis is equivalent for $j = 1, 2$. For the sake of simplicity, we will just discuss the non-linear interaction up to first order $g(z) \approx g_0 + g_1 z$ but the same procedure can be easily applied to the case $g(z) \approx g_0 + g_2 z^2$.

We consider the complete system and write the equations of motion as;

$$\begin{aligned} m \left[\ddot{z}(t) + \gamma_m \dot{z}(t) + \left(\omega_m^2 + \sqrt{L/m} g_1 \dot{q}(t) \right) z(t) \right] \\ + \sqrt{Lm} g_0 \dot{q}(t) = 0 \\ L \left[\ddot{q}(t) + \gamma_e \dot{q}(t) + \omega_e^2 q(t) \right] - \sqrt{Lm} g_1 z(t) \dot{z}(t) \\ - \sqrt{Lm} g_0 \dot{z}(t) = 0. \end{aligned} \quad (4)$$

The first equation is for the mechanics and the second is for the electronics. We observe that (4) are coupled differential equations. The current $\dot{q}(t)$ in the LC circuit produces a magnetic field that exerts a force which affects the stiffness of the mechanical spring, modify the spring constant as $k(\dot{q}) = k_0 + \dot{q}(\partial k/\partial \dot{q})$ and the mechanical resonance frequency to $\Omega_m = \sqrt{k(\dot{q})/m}$. We are interested in the generalized dynamics of the magnetomechanical system and for its later quantization. For this reason, we require to determine the lossless magnetomechanical Lagrangian $\mathcal{L}$ that describes the equations of motion (4)

$$\begin{aligned} \mathcal{L}(z, q, \dot{z}, \dot{q}) = \left(\frac{m}{2} \dot{z}^2 - \frac{m}{2} \omega_m^2 z^2 \right) + \left(\frac{L}{2} \dot{q}^2 - \frac{L}{2} \omega_e^2 q^2 \right) \\ + \sqrt{Lm} g(z) z \dot{q} + \varphi \frac{d}{dt}(zq). \end{aligned} \quad (5)$$

The first two terms in Eq. (5) describes the two oscillators. The third term is the magnetomechanical coupling between the motional displacement, and the small currents $\dot{q}(t)$. The last term is a total derivative, which leaves the coupled equations of motion (4) invariant. Any arbitrary value may be chosen for φ , here, we choose $\varphi = -\sqrt{Lm} g_0$ to simplify the ultimate form of the Hamiltonian plus recover the external capacitance in the readout circuit $C_k = 1/(Lg_0^2)$, due to the coupling g_0 [6]. Applying the Legendre transformation $\mathcal{H}(z, q, p, \phi) = \dot{z}p + \dot{q}\phi - \mathcal{L}$ to Eq. (5), one obtains the generalized mechanical and electrical conjugate momenta of the oscillators

$$\frac{\partial \mathcal{L}}{\partial \dot{z}} = p = m\dot{z} - \sqrt{Lm} g_0 q, \quad \frac{\partial \mathcal{L}}{\partial \dot{q}} = \phi = L\dot{q} + \sqrt{Lm} g_1 z. \quad (6)$$

The total conjugate mechanical momentum p of the coupled system includes the kinetic momentum $m\dot{z}$ and the Hamiltonian is then

$$\mathcal{H} = \left(\frac{\phi^2}{2L} + \Omega_e^2 \frac{Lq^2}{2} \right) + \left(\frac{p^2}{2m} + \Omega_m^2 \frac{mz^2}{2} \right) + \sqrt{\frac{L}{m}} g_0 pq. \quad (7)$$

The coupling between the oscillators produces a simultaneous shift on the resonance frequencies, electrical $\Omega_e = \sqrt{\omega_e^2 + g_0^2}$ and the mechanical Ω_m . This shifted mechanical frequency Ω_m takes different forms whether we work on the linear or non-linear regime and we define it in terms of the coupling in Eq. (9). Following the standard process in opto- and electro-mechanics [32], we quantize the classical Hamiltonian (7) with the standard commutation relations $[\hat{q}, \hat{p}] = [\hat{z}, \hat{\phi}] = [\hat{z}, \hat{q}] = [\hat{p}, \hat{\phi}] = 0$, and $[\hat{q}, \hat{\phi}] = [\hat{z}, \hat{p}] = i\hbar$. The quantum magnetomechanical Hamiltonian $\hat{H}_m$ for the two coupled oscillators is finally written as

$$\hat{H}_m = \left(\frac{\hat{\phi}^2}{2L} + \Omega_e^2 \frac{L\hat{q}^2}{2} \right) + \left(\frac{\hat{p}^2}{2m} + \Omega_m^2(\hat{\phi}) \frac{m\hat{z}^2}{2} \right) + g_0 \sqrt{\frac{L}{m}} \hat{p}\hat{q}. \quad (8)$$

The interaction introduces the Lorentz spring constant is $k_L = -2g_1\sqrt{m/L}$ producing a shift in the mechanical frequency

$$\Omega_m^2(\hat{\phi}) = \omega_m^2 - \frac{2g_1}{\sqrt{Lm}} \hat{\phi}. \quad (9)$$

The shifted mechanical resonance frequency Ω_m can be tuned electrically by applying a DC electrical current. If an AC current arises in the electrical circuit, the mechanical oscillator can be parametrically driven.

III. QUANTUM DYNAMICS

In this section we discuss some of the properties of this magnetomechanical system. We explore the quantum Hamiltonian and study in detail the linearized version of it. We describe some of the potential applications of a quantum system of this nature. The general Hamiltonian (8) describes the dynamics of the entire magnetomechanical system. Since in general $|g_0| \gg |g_1|$, and terms involving g_1^2 are usually negligible, we can write the magnetomechanical Hamiltonian as a sum of linear and non-linear terms, i.e. $\hat{H}_m = \hat{H}_L + \hat{H}_{NL}$, where

$$\hat{H}_L = \frac{\hat{\phi}^2}{2L} + \Omega_e^2 \frac{L\hat{q}^2}{2} + \frac{\hat{p}^2}{2m} + \omega_m^2 \frac{m\hat{z}^2}{2} + g_0 \sqrt{\frac{L}{m}} \hat{p}\hat{q}, \quad (10)$$

and

$$\hat{H}_{NL} \approx g_1 \sqrt{\frac{m}{L}} \hat{z}^2 \hat{\phi}. \quad (11)$$

with H_L we recover the system studied in Ref. [6] used for quantum non demolition measurements and velocity sensing. An external stress applied by the magnetic field generated by the circuit induces additional stiffness to the spring constant due to the Lorentz force

$$\hat{F}_L = -\frac{\partial \hat{H}_{int}}{\partial \hat{z}} = 2g_1 \sqrt{\frac{m}{L}} \hat{z} \hat{\phi}. \quad (12)$$

Properties of the Lorentz force have been investigated and shown that mechanical cooling can be achieved using back action of the Lorentz force [33]. The non-linear properties of the Hamiltonian (8) represent a new scenario for the non-linear dynamics of mechanical systems [34, 35]

A. Solution in the linear regime

In regular optomechanics, the interaction is commonly described by a linearized model with a bi-linear position-position coupling [36]. In this section, we focus our study on the linear magnetomechanical Hamiltonian $\hat{H}_L$, where $g_0 \gg g_1$. This raises a dominant linear interaction defined by the charge-momentum coupling $\hat{q}\hat{p}$. Charge-momentum coupling remains little explored, and to the best of our knowledge there are no proposals demonstrating that ultra-strong coupling for mechanical systems can be achieved in this fashion.

For the linear magnetomechanical system, the Heisenberg equations of motion are linear and may be solved by the method of normal modes. Here we set the basic description for the mechanical response. We can find a canonical (unitary) transformation to diagonalize the Hamiltonian (10) following [37]. The linear lossless coupled Hamiltonian (10) can then be expressed in the normal mode basis as two independent oscillators that resonate at the normal mode frequencies

$$\tilde{H} = \omega_-^2 \frac{\hat{X}_-^2}{2} + \frac{\hat{P}_-^2}{2} + \omega_+^2 \frac{\hat{X}_+^2}{2} + \frac{\hat{P}_+^2}{2}, \quad (13)$$

where the position $\hat{X}_\pm$ and momentum $\hat{P}_\pm$ dimensionless quadratures are defined as

$$\begin{aligned} \hat{X}_+ &= (\hat{q} \cosh \beta + \frac{\hat{p}}{y_r} \sinh \beta) / q_0, \\ \hat{X}_- &= (\hat{z} \cosh \beta + \frac{\hat{\phi}}{y_r} \sinh \beta) / z_0, \\ \hat{P}_+ &= (\hat{\phi} \cosh \beta + y_r \hat{z} \sinh \beta) / \phi_0, \\ \hat{P}_- &= (\hat{p} \cosh \beta + y_r \hat{q} \sinh \beta) / p_0 \end{aligned} \quad (14)$$

where $y_r = i \sqrt{Lm} \omega_e$ and $e^{4\beta} = \frac{1-i\sigma}{-1-i\sigma}$, with $\sigma = \frac{\omega_e^2 - \omega_m^2}{2\omega_e g_0}$. The different zero point fluctuation are, for mechanical $z_0 = \sqrt{\hbar/(2m\omega_m)}$, for charge $q_0 = \sqrt{\hbar/(2L\Omega_e)}$, for mechanical momentum $p_0 = \sqrt{\hbar m \omega_m / 2}$ and for flux $\phi_0 = \sqrt{\hbar L \Omega_e / 2}$.

A simplified version of the linear magnetomechanical system, considers a lossless environment $\gamma_{m,e} = 0$. The normal modes are new hybrid eigenmodes, their properties no longer can be attributed to the individual properties of either the LC resonator or the mechanical oscillator. The eigenfrequencies of the normal modes are given by

$$\omega_\pm^2 = \frac{1}{2} \left(\omega_m^2 + \Omega_e^2 \pm \sqrt{16g_0^2 \Omega_e^2 + (\omega_m^2 - \Omega_e^2)^2} \right). \quad (15)$$

At this point, the dynamics of the magnetomechanical system purely describes it in the absence of decoherence. As real systems are in contact with the environment, we consider the presence of decoherence channels $\gamma_e, \gamma_m \neq 0$. We are interested in the mechanical response of the oscillator to external excitations. We consider the Heisenberg equations of motion derived from $\hat{H}_L$ in the presence of an external sinusoidal drive force $\tilde{F}_{ext}(\omega)$ with frequency ω . The value $\tilde{\mathcal{O}}(\omega)$ represents the Fourier transform of $\mathcal{O}(t)$. The mechanical response to the external drive is dependent on the susceptibility of the mechanics $\chi_m(\omega) = (m(\omega_m^2 - \omega^2 + i\omega\gamma_m))^{-1}$. The frequency dependent harmonic displacement due to an external drive is $\tilde{z}(\omega) = \chi_m(\omega) \tilde{F}_{ext}(\omega)$. The coupling between the mechanical and electrical oscillators will produce the presence of an external voltage on the circuit $\tilde{V}_{ext}(\omega)$, inducing a modification to the susceptibility on the mechanics $\chi_{eff}(\omega)^{-1} = \chi_m^{-1} + \Sigma(\omega)$, where $\Sigma(\omega) = \frac{mg_0^2 \omega^2}{\omega_e^2 - \omega^2 + i\gamma_e \omega}$. The mechanical response in the frequency domain is then

$$\tilde{z}(\omega) = \chi_{eff}(\omega) \left[\tilde{F}_{ext}(\omega) + \tilde{V}_{ext}(\omega) \left(\frac{g_0 \sqrt{\frac{m}{L}} \omega}{\omega_e^2 - \omega^2 + i\gamma_e \omega} \right) \right] \quad (16)$$

where the first term corresponds to the response due to the Lorentz force and the second term corresponds to the back action of the electrical current on the mechanics. The mechanical oscillator will then be resonant to these normal modes. This eigenfrequencies are altered $\omega_\pm \rightarrow \Omega_\pm$ due to the damping. The coupled system with $\gamma_{m,e} \neq 0$ has finally the eigenfrequencies

$$\Omega_\pm^2 = \frac{1}{2} \Xi^2 \pm \frac{1}{2} \sqrt{4g_0^2 \omega_m^2 + \Xi^4 - 4\omega_m^2 \Omega_e^2} \quad (17)$$

where $\Xi^2 = \omega_m^2 + \Omega_e^2 + \gamma_e \gamma_m$.

The mechanical response is shown in Fig. 2, where the normal mode frequencies $\Omega_{\pm}$ are shown in Fig. 2a and 2b as red dashed lines. The damping rates $\gamma_{m,e}$ are represented as the width of the eigenmodes. An avoided crossing with splitting $\Omega_+ - \Omega_- \approx 2g_0$ is observed in Fig. 2a and Fig. 2b, which is a signature of strong coupling between the modes, showing that strong coupling can be achieved in the linear regime of this magnetomechanical system. In Fig. 2a and 2c the considered values are $(\gamma_m, \gamma_e, g) = (0.025\omega_m, 0.05\omega_m, 0.1\omega_m)$. In Fig. 2b and 2d the considered values are $(\gamma_m, \gamma_e, g) = (0.025\omega_m, 0.05\omega_m, 0.3\omega_m)$. The Fig. 2c and 2d show two plots for $\tilde{z}(\omega)$ values of ω_e , in green $\omega_e = 0.8\omega_m$ and orange $\omega_e = 1.2\omega_m$. These results show that normal mode splitting can be achieved for mechanical oscillators with mechanical quality factor $Q_m = \omega_m/\gamma_m = 40$ for a system with the characteristics described in the next section.

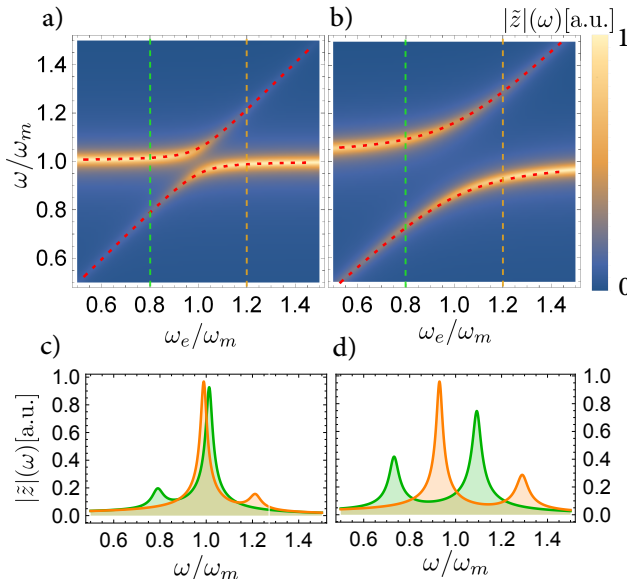


FIG. 2: a) Plot of the mechanical response considering the parameters $(\gamma_m, \gamma_e, g_0) = (0.025, 0.05, 0.1) \times \omega_m$ as a function of the frequency ω/ω_m and ω_e/ω_m , where we set $m = L = 1$. The normal modes frequencies $\Omega_{\pm}$ are shown as red dashed lines and avoided crossing is observed. For $\omega_e = 0.8\omega_m$ (green dashed line) and $\omega_e = 1.2\omega_m$ (orange dashed line) we show the profile in Fig. 2c. b) Plot of the mechanical response considering the parameters $(\gamma_m, \gamma_e, g_0) = (0.025, 0.05, 0.3) \times \omega_m$ as a function of the frequency ω/ω_m and ω_e/ω_m . The normal modes frequencies $\Omega_{\pm}$ are shown as red dashed lines and avoided crossing is observed. For $\omega_e = 0.8\omega_m$ (green dashed line) and $\omega_e = 1.2\omega_m$ (orange dashed line) we show the profile in Fig. 2d.

IV. MAGNETOMECHANICAL SYSTEM

Up to this point, we have treated the magnetomechanical system in a general fashion. Here we describe a concrete experimental design that includes technical details regarding its fabrication and practical implementation. The main motivation behind this hybrid system is to build an on-chip feasible magnetomechanical setup which is able to explore strong magnetomechanical interactions. Our model considers experimental micro and nano fabrication techniques and design, which are currently available. In this particular design we study mostly the influence on the coupling rate g_0 due to the geometry and factors such as the height of the magnet h_m , relative equilibrium vertical distance between the magnet and the coil u_0 , number of turns of the inductor/coil N and width w of the wire/separation. The magnetomechanical system is in principle able to achieve coupling rates g_0 that exceed the values of the mechanical resonance frequency ω_m which is extremely challenging for optomechanical systems.

The mechanical oscillator is taken to be formed by a double clamped beam $10\mu\text{m}$ long and $1\mu\text{m}$ wide. This beam is made from an etched Si_3N_4 membrane as we depict in Fig. 3a where the etched Si_3N_4 beam has boundaries, which are smoothly terminated [38]. It has been reported, Si_3N_4 has exceptional mechanical properties under cryogenic conditions [39], which makes it suitable for future magnetomechanical setups. The cylindrical magnet is formed at the center of the beam through deposition of thin film magnetic material, similar to the coating process for cantilever's AFM magnetized tips. Is important to highlight that the remarkable mechanical properties of Si_3N_4 membranes remain largely unchanged when thin films are deposited on it [40]. Mechanical oscillators made out of Si_3N_4 membranes have typical values for mechanical quality factor $Q_m = \omega_m/\gamma_m = 10^5$. The thickness of the magnet

h_m can be easily controlled during the deposition of the magnetic film. The process to pattern the cylindrical magnet can be using lift-off standard process used in e-beam lithography.

Another important component of the coupled system is the micro/nano fabricated coil depicted in Fig. 3b. Several techniques have been implemented in recent years where inductors have been successfully nanofabricated [12, 41, 42]. A schematic representation of a spiral coil is shown in Fig. 3b, we also show a transverse cut to define w as the packing parameter. The packing parameter represents the width of the wire but also the spacing between each one of the wires that make a single turn. The maximum resolution of a nanofabrication system will determine the minimum value for w . The successful implementation of our magnetomechanical system requires a fabrication process separated in two main steps. The first, the fabrication of the mechanical oscillator on chip, where the magnet lays on top of the Si_3N_4 like membrane as shown in Fig. 3a. The second, the fabrication of the electronic system on a different chip, we represent the coil in Fig. 3b. The chip containing the mechanical oscillator can then be flipped and adjusted to the desired separation between the magnet and the coil as the it is represented in the scheme Fig. 3c. These flipped joint chips form a system similar to the state of the art 3D cavities recently developed [43, 44].

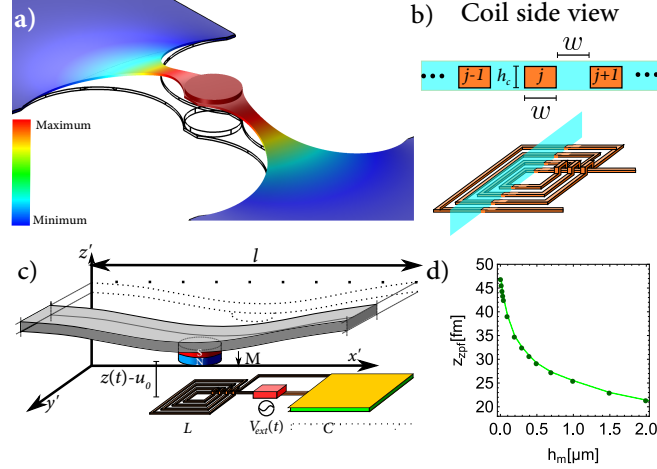


FIG. 3: a) Diagram of the fundamental mechanical mode of a double clamped beam made out of a Si_3N_4 membrane smoothly etched. The membrane has a cylinder on top that represents the magnet. b) Diagram of the coil on the electronic chip. In blue an axial plane cut showing the transversal area $w \times h_c$ of each wire of the coil. The width and spacing is w and h_c is the thickness of the wire. c) Representation of the flipped chip approach that places the double clamped beam resonator above the electronic chip. d) Plot of the zero point fluctuation z_{zpf} for the fundamental mode as a function of the thickness/height of the magnet h_m .

The magnetic flux from the magnet will determine the magnitude of the interaction. It is desirable to have magnetic materials that support high density magnetization in thin films. A magnetic material with such characteristics and which has been extensively studied is, for example one of many cobalt-alloys [45]. In this design, we consider a standard Co-Fe alloy with density $\rho_m = 7.81\text{g/cm}^3$ and a conservative value for the magnetization $|\mathbf{M}| = 0.264\text{ T}$. Commercial alloys of this type can be easily magnetized to values of $|\mathbf{M}| = 1\text{ T}$.

The finite element model [46] in Fig. 3a shows the fundamental motional mode shape of the loaded double clamped beam. The radius of the magnet is fixed to $r_m = 0.5\text{ }\mu\text{m}$ and is a suitable size for e-beam lithography, and the only degree of freedom that we explore now is the height of the magnet h_m . The thickness of this film will influence the mechanical parameters but also on the coupling rate. In Fig. 3d we plot the zero point motion $z_0 = \sqrt{\frac{\hbar}{2m\omega_m}}$ as a function of the magnet thickness h_m . By controlling the thickness of the deposited magnetic material, we can easily alter both ω_m and m . We calculate the effective mass m and the resonance frequency ω_m for the fundamental mechanical mode of the mechanical system as a function of h_m , shown in Fig. 4a. The control and tuning of the mechanical frequency has two different limits. In one limit, films which are only a few nanometers thick will result in a higher frequency mechanical oscillator, making the interaction with the LC circuits technically more feasible. On the other hand, thicker films results in higher magnetic volumes and therefore stronger magnetic interactions.

We derive the magnetic scalar potential Φ_m for a cylindrical magnet, then its gradient $\nabla\Phi_m$ to determine the magnetic field components B_z and B_r and its spatial distribution as described in section II. Considering Eq.(1) and the initial separation u_0 , we can numerically estimate the value $g_0 = g(u_0)$ as a function of several parameters, such as the gap between the edge of the magnet $\mathcal{T}$, the number of turns of the coil N and the packing parameter w that represents the width and separation between the wires of the coil.

The numerical results for the ratio of the coupling rate and the mechanical frequency g_0/ω_m as a function of three

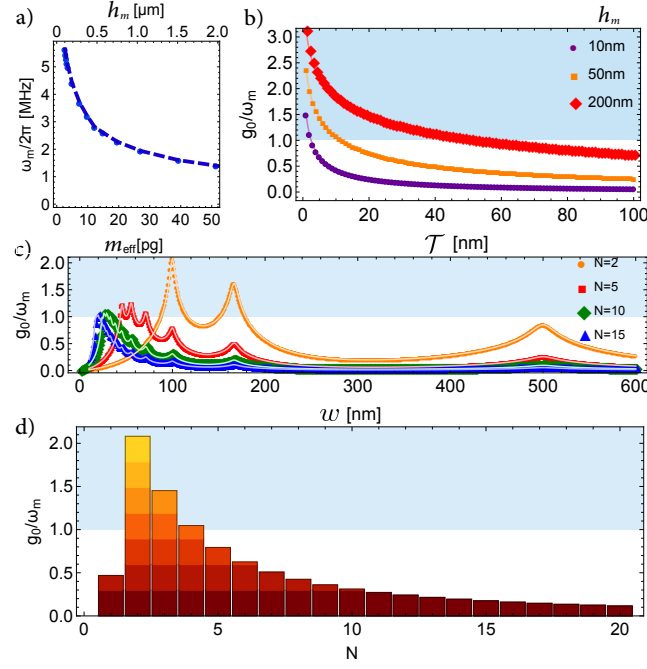


FIG. 4: a) Plot of ω_m as a function of h_m and m of the fundamental mode. b) Determination of the ratio g_0/ω_m as a function of $\mathcal{T}$ for $h_m = 10\text{ nm}$, $h_m = 50\text{ nm}$ and $h_m = 200\text{ nm}$. The parameters considered here are $w = 100$ and $N = 2$ of the inductor. In red the thickest magnet of $h_m = 200\text{ nm}$. In orange the curve that corresponds to $h_m = 50\text{ nm}$. In purple, the curve that corresponds to $h_m = 10\text{ nm}$. c) Estimation of g_0/ω_m as a function of w . In these results $h_m = 200\text{ nm}$, with the one, the oscillator has an effective mass $m = 9.9 \times 10^{-15}\text{ kg}$ and a mechanical resonant frequency $\omega_m/2\pi = 3.2\text{ MHz}$. The gap considered in this result is $\mathcal{T} = 10\text{ nm}$. In blue, the curve corresponding to $N = 15$, in green $N = 10$, in red $N = 5$ and orange $N = 2$. d) Ratio g_0/ω_m as a function of N . The numerical values were calculated considering a cylindrical magnet with $h_m = 200\text{ nm}$, $\mathcal{T} = 10\text{ nm}$ and $w = 100\text{ nm}$. All the calculations were performed considering a magnetization $|M| = 0.264\text{ T}$.

different parameters are shown in Fig. 4a, 4b and 4c. In Fig. 4b the ratio g_0/ω_m is presented as a function of the gap $\mathcal{T} = u_0 - h_m/2$ between the coil and the edge of the magnet, for different thickness of the magnet h_m and with $(N; w) = (2; 100\text{ nm})$. It is observable that the same tendency is followed for different thickness of the magnetic film. As h_m and the magnetic volume increase, the maximum of the coupling rate achievable increases, but not linearly. Fig. 4b shows a region in blue, where ratios of $g_0/\omega_m > 1$, leads to physics in the deep-strong coupling regime. The importance of this result relies on the unexplored regime for mechanical systems. This regime has been recently observed in superconducting qubits [24]. Fig. 4c shows numerical simulations of g_0/ω_m as a function of w with parameters $(N; h_m; \omega_m) = (2; 200\text{ nm}; 2\pi \times 3.2\text{ MHz})$. For this calculation we considered a magnet with $h_m = 200\text{ nm}$ that has associated an effective mass $m = 9.9 \times 10^{-15}\text{ kg}$ and whose mechanical resonant frequency for the fundamental mode is $\omega_m/2\pi = 3.2\text{ MHz}$. This magnet is separated $\mathcal{T} = 10\text{ nm}$ from the spiral coil. We calculate the ratio g_0/ω_m as a function of w for different values of N . We observe that N is also an important parameter due to its contribution to the inductance L . The inductance L of the spiral square inductor was calculated with finite element methods software [46] and compared with analytical expressions [47]. The two methods yielded similar results, as we chose to use the analytical expressions for simplicity and accuracy. The last parameter discussed in this paper is the enhancement of the coupling rate g_0 due to the number of turns of the nano fabricated coil. In Fig. 4d we plot the coupling rate ratio g_0/ω_m as a function of N keeping the parameters $(\mathcal{T}; h_m; \omega_m) = (10\text{ nm}; 200\text{ nm}; 2\pi \times 3.2\text{ MHz})$ fixed while maximising over w . We observe that at $N = 2$ the maximum ratio is obtained, which yields to deep-strong coupling. The inductance L in the LC circuit plays a similar role than the mass m on the mechanics, therefore a small inductance in the electronics favours the coupling.

V. CONCLUSION

The magnetomechanical system that we have proposed here provides a suitable instrument to explore the regime of ultra-strong and deep-strong coupling for linear dynamics of mechanical systems. It also provides an interaction Hamiltonian coupled through the momentum $\hat{p}\hat{q}$, making accessible the implementation of novel protocols of back

action evading measurements. We also note that the Hamiltonian breaks time symmetry due to its linear dependence on the mechanical momentum. Considering the recent exponential progress in experimental techniques and fabrication processes such as photo and e-beam lithography, we consider that our magnetomechanical system can be implemented.

We predict this large coupling g_0 potentially achieved in quantum magnetomechanics. This coupling facilitates the implementation of already existing optomechanical protocols (manipulation, control, cooling etc.), as it does not require ultra high Q_m mechanical resonators. The second order interaction ($\hat{\phi}\hat{z}^2$) induces an x -squared type non-linearity allowing manipulation of depth of the harmonic potential and implementation of effects such as squeezing of the mechanics [48].

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